

 <p>OIPF INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)</p>				Docket Number (Optional) 82478-2400		Application Number 10/719,774		
				Applicant(s) Shinichi Tanimoto et al.				
				Filing Date 11/21/2003		Group Art Unit 2825		
U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
NL		6,631,509	10/7/2003	Nakayama et al.				
U.S. PATENT APPLICATION PUBLICATIONS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
NL		2004-015804	1/22/2004	Nakayama et al.				
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
NL		2002-016337	18.01.2002	Japan w/English abstract			✓	
NL		2001-282882	12.10.2001	Japan (see USP 6,631,509			✓	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)								
EXAMINER <i>Nam Len</i>				DATE CONSIDERED <i>01/23/06</i>				
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